

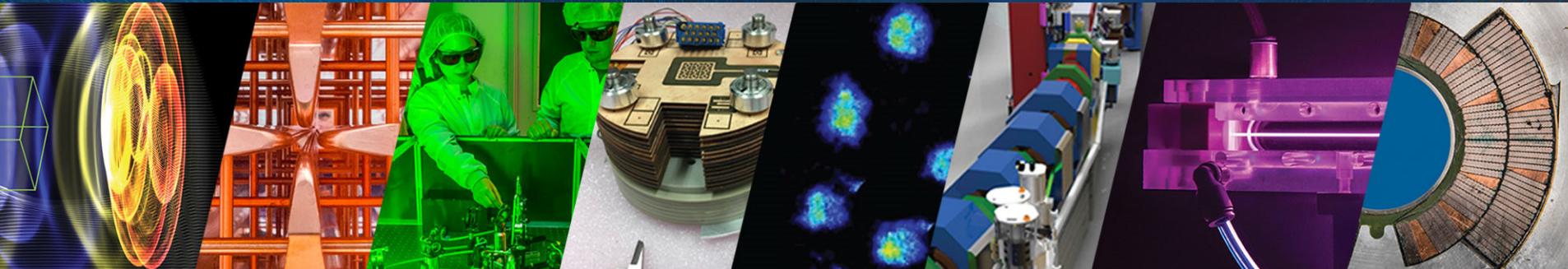
# Micro-electromechanical systems based multi-beam ion accelerators

Qing Ji<sup>a</sup>, Ariel Amsellem<sup>a</sup>, Nicholas Valverde<sup>a</sup>, Arun Persaud<sup>a</sup>, Zhihao Qin<sup>a</sup>, Peter A. Seidl<sup>a</sup>, Thomas Schenkel<sup>a</sup>, Yuetao Hou<sup>b</sup>, Di Ni<sup>b</sup>, Ved Gund<sup>b</sup>, Khurram K. Afridi<sup>b</sup>, Amit Lal, Steve Lund<sup>c</sup>, and Thomas Schenkel<sup>a</sup>

<sup>a</sup>Lawrence Berkeley National Laboratory

<sup>b</sup>Cornell University

<sup>c</sup>Michigan State University



8/10/2022

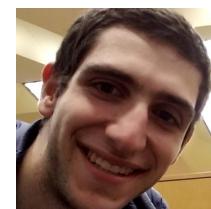
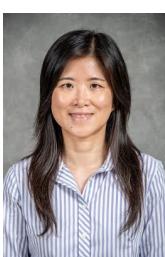


ACCELERATOR TECHNOLOGY &  
APPLIED PHYSICS DIVISION



Office of  
Science

# This R&D work has been a collaborative effort between LBNL and Cornell University.



T. Schenkel (PI)    Q. Ji    A. Persaud    P. Seidl,    Z. Qin,    A. Amsellem,    N. Valverde

- Accelerators, beam physics, ion sources and beam transport, RF, ...  
<http://atap.lbl.gov/>



A. Lal (co-PI)

K. K. Afridi

D. Ni

Y. Hou

V. Gund

- MEMS fabrication, Chip-scale particle accelerators, RF power amplifier ...  
<http://www.sonicmems.ece.cornell.edu/>



U.S. DEPARTMENT OF  
**ENERGY**

Office of  
Science

ACCELERATOR TECHNOLOGY &  
APPLIED PHYSICS DIVISION



# Examples of high power ion accelerators at Berkeley Lab



U.S. DEPARTMENT OF  
**ENERGY**

Office of  
Science

ACCELERATOR TECHNOLOGY &  
APPLIED PHYSICS DIVISION

**ATAP**

# Examples of high power ion accelerators at Berkeley Lab



- Pulsed induction linac (12 m)
- 1 MeV, 2 ns, mm,  $\geq 2$  A peak
- 200x drift compression
- P. A. Seidl et al. NIM A (2015)



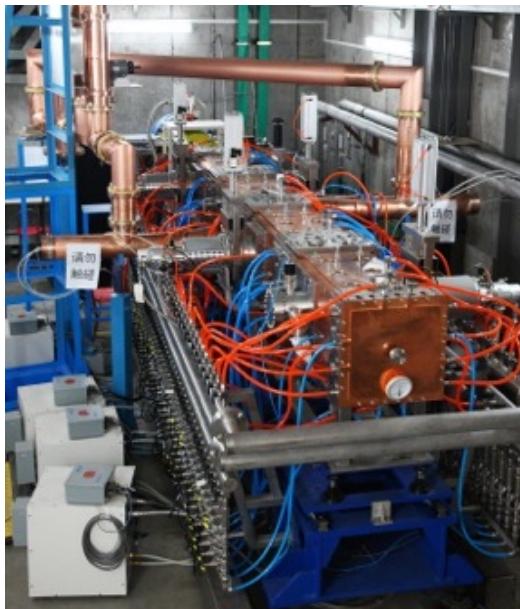
U.S. DEPARTMENT OF  
**ENERGY**

Office of  
Science

ACCELERATOR TECHNOLOGY &  
APPLIED PHYSICS DIVISION

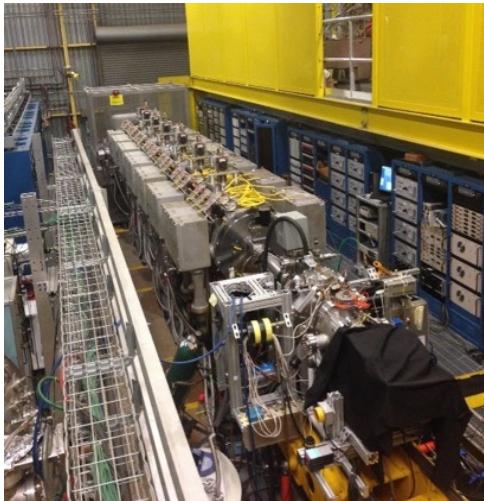
**ATAP**

# Examples of high power ion accelerators at Berkeley Lab

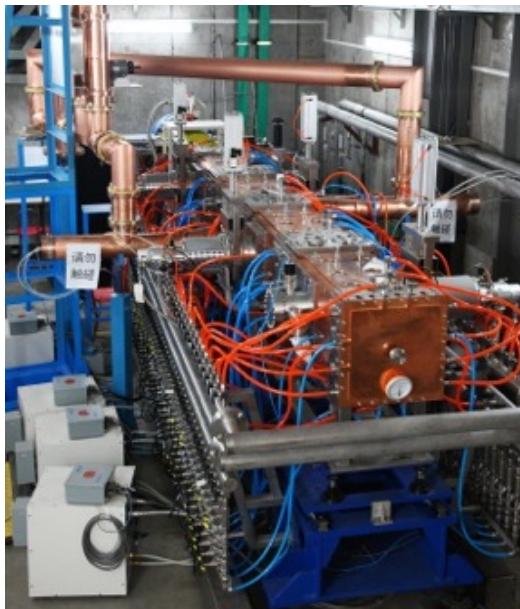


- Pulsed induction linac (12 m)
- 1 MeV, 2 ns, mm,  $\geq 2$  A peak
- 200x drift compression
- P. A. Seidl et al. NIM A (2015)
- Radio frequency quadrupole (RFQ)
- 2 MeV, 0.01 A, cw
- 4 m long, 0.4 m cross section
- Z. Zouhli, D. Li et al. IPAC2014

# Examples of high power ion accelerators at Berkeley Lab



- Pulsed induction linac (12 m)
- 1 MeV, 2 ns, mm,  $\geq 2$  A peak
- 200x drift compression
- P. A. Seidl et al. NIM A (2015)



- Radio frequency quadrupole (RFQ)
- 2 MeV, 0.01 A, cw
- 4 m long, 0.4 m cross section
- Z. Zouhli, D. Li et al. IPAC2014

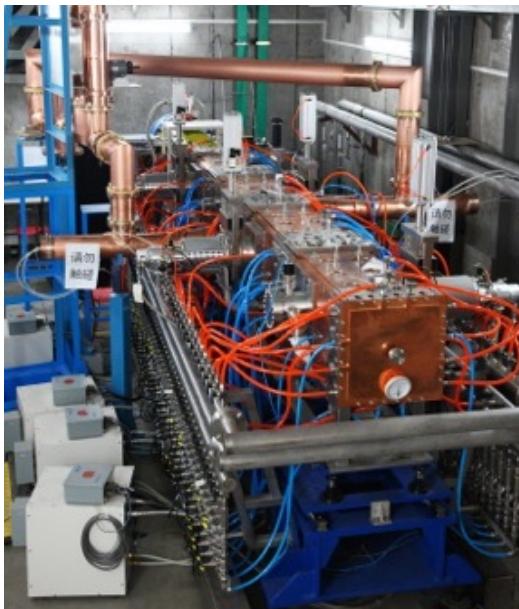


- High Current Experiment
- injection, matching and transport at heavy ion fusion driver scale
- 1 MeV, 0.2 A, 5  $\mu$ s,  $\sim 12$  m
- 0.4 m cross section
- M. Kireeff-Covo, et al., PRL (2006)

# Examples of high power ion accelerators at Berkeley Lab



- Pulsed induction linac (12 m)
- 1 MeV, 2 ns, mm,  $\geq 2$  A peak
- 200x drift compression
- P. A. Seidl et al. NIM A (2015)



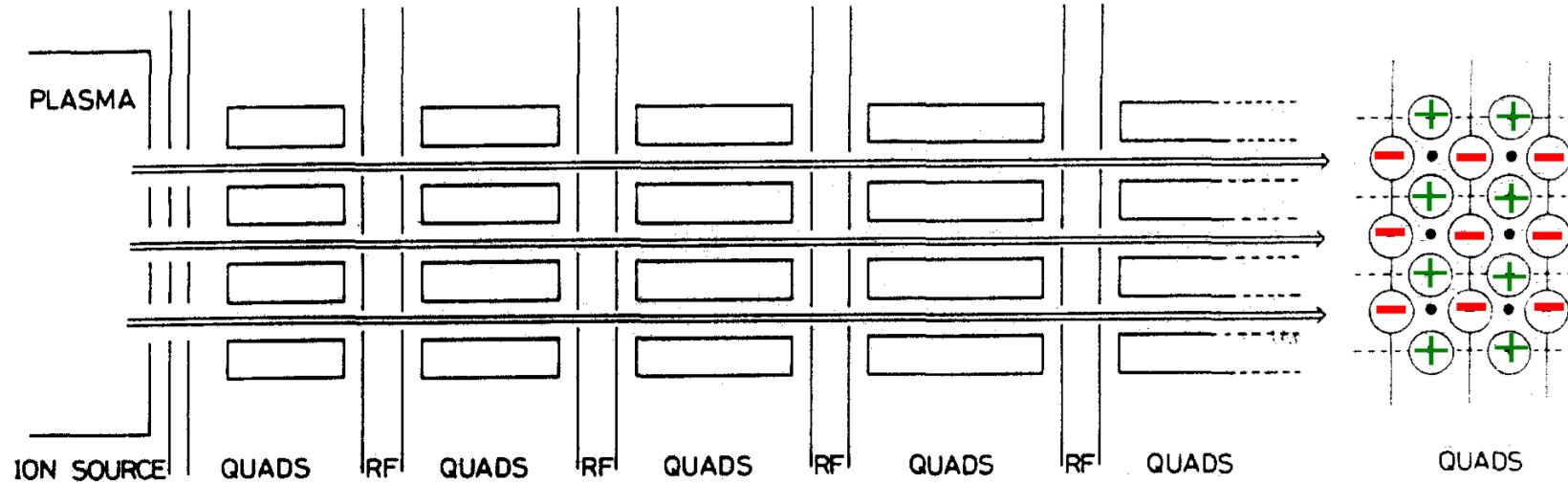
- Radio frequency quadrupole (RFQ)
- 2 MeV, 0.01 A, cw
- 4 m long, 0.4 m cross section
- Z. Zouhli, D. Li et al. IPAC2014



- High Current Experiment
- injection, matching and transport at heavy ion fusion driver scale
- 1 MeV, 0.2 A, 5  $\mu$ s,  $\sim 12$  m
- 0.4 m cross section
- M. Kireeff-Covo, et al., PRL (2006)

**Can we scale ion beams to higher power at lower cost?  
MEMS based multi-beam linacs**

# Multiple-Electrostatic-Quadrupole-Array Linear Accelerator (MEQALAC) concept from 1980s

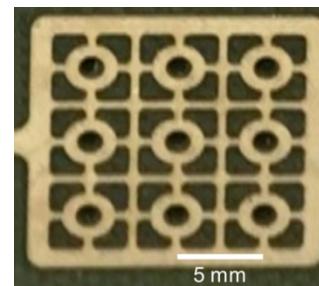
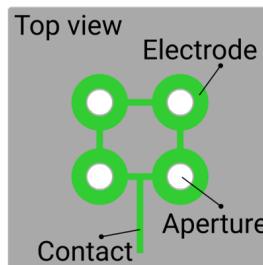
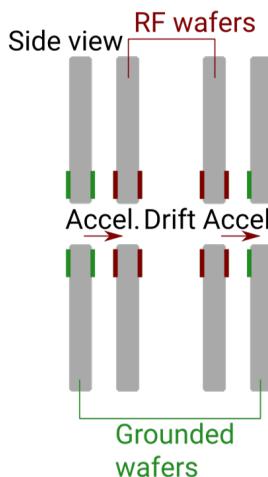


- Accelerator with many beamlets enables higher total ion currents, higher beam power and higher current densities
- '80s: ~ 1 cm beam aperture, electrostatic quadrupole (ESQ), ~15 MHz RF cavities
  - Thomae et al., Mat. Science & Eng., B2, 231 (1989)
  - Al Maschke et al., early 1980s

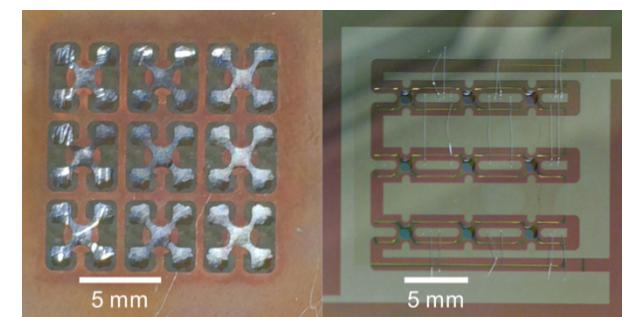
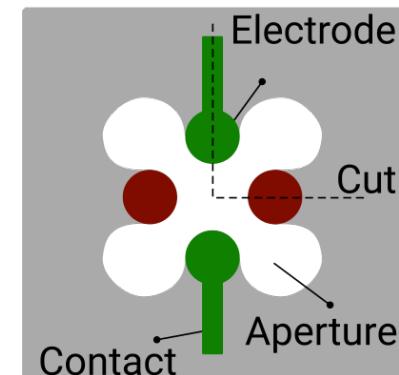
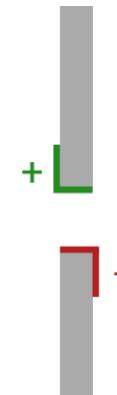
# We achieved miniaturization of acceleration and focusing elements using MEMS technology.

RF - acceleration

$$\text{Drift} = \beta \lambda/2 = \frac{1}{2} v_{\text{ion}}/f_{\text{RF}}$$

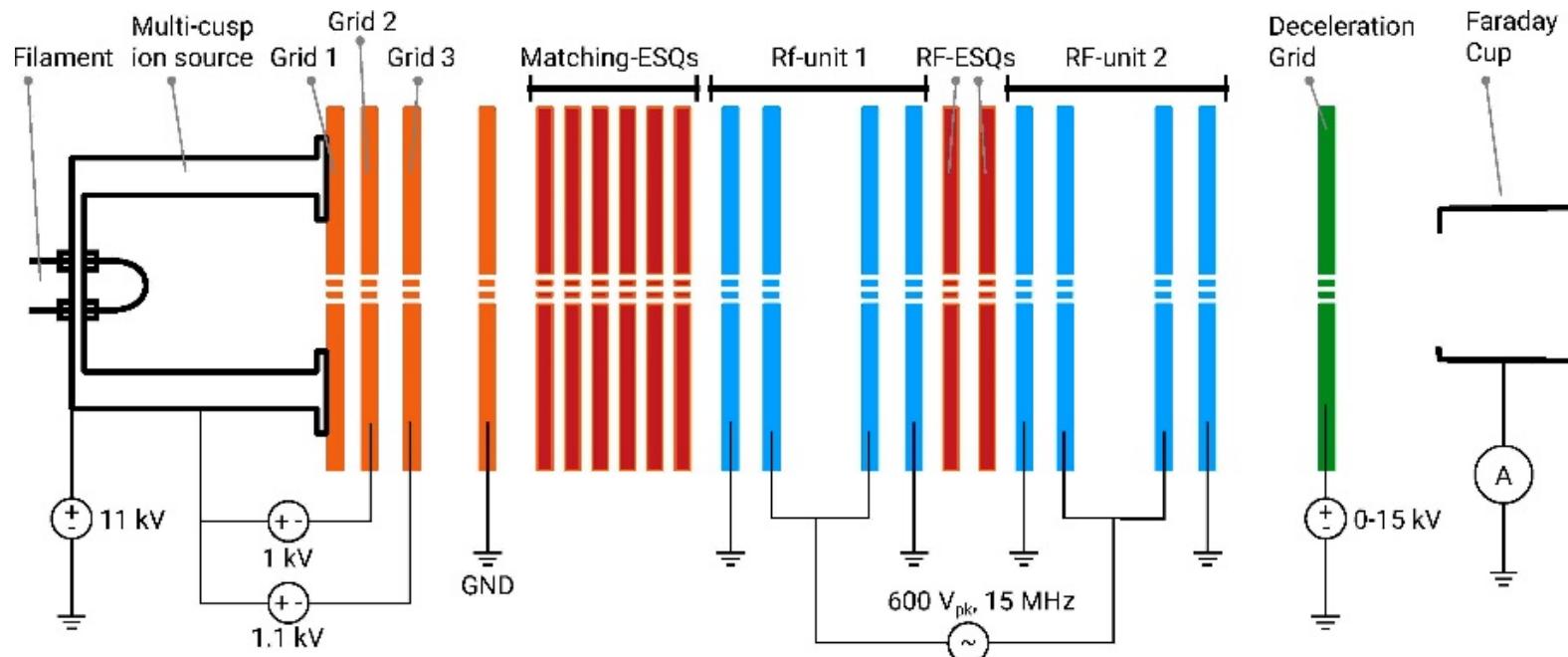


Electrostatic  
Quadrupoles



- Persaud, et al., Rev. Sci. Instr. 88, 063304 (2017)
- Persaud, et al., Phys. Procedia 90, 136 (2017)
- Seidl, et al., Rev. Sci. Instr. (2018)
- Vinayakumar, et al., J. Appl. Phys. 125, 194901 (2019)

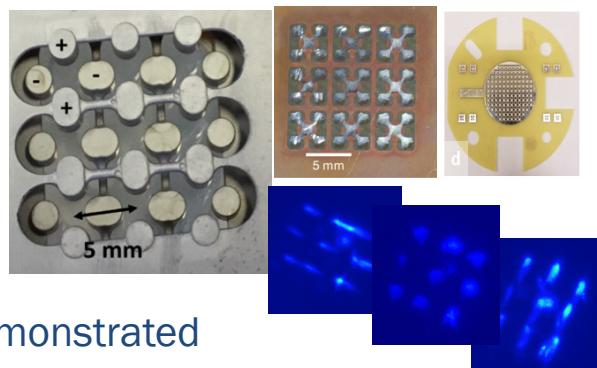
# Ion acceleration and focusing have been demonstrated using a stack of wafers. The total ion current is scaled with more beamlets.



## Beam extraction

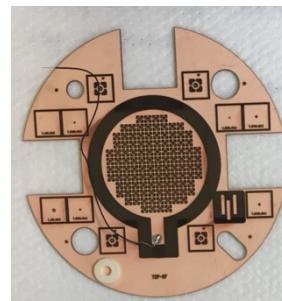


## Focusing



up to 0.5 mA of Ar<sup>+</sup> demonstrated

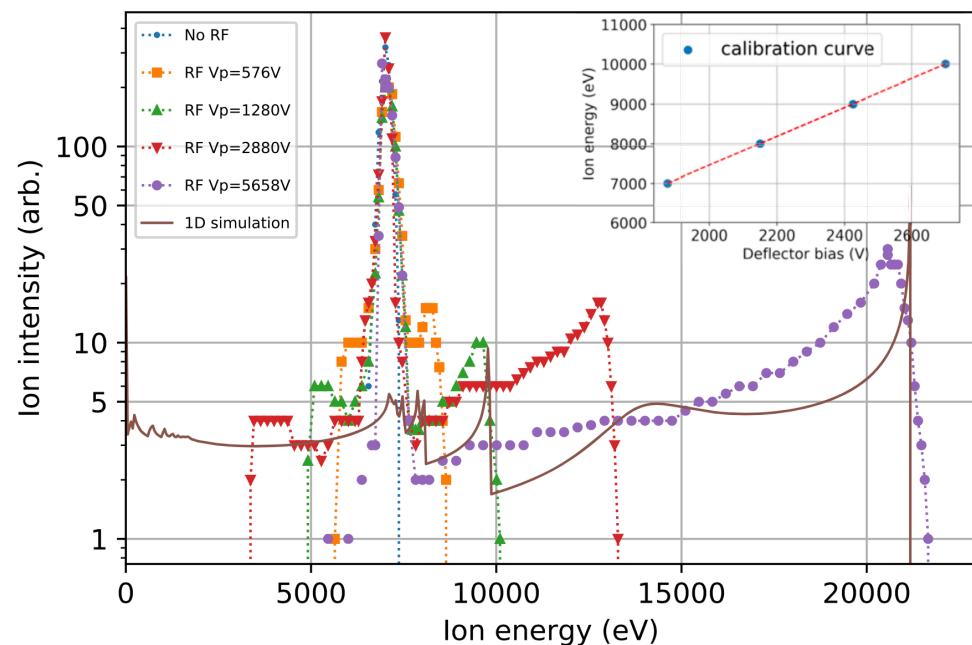
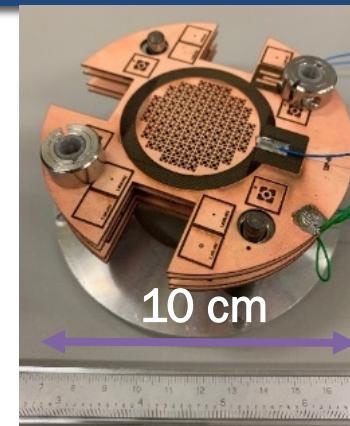
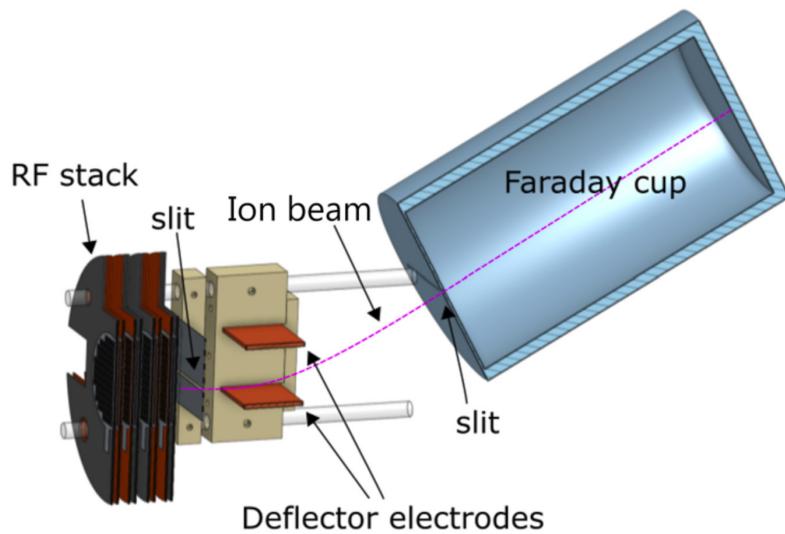
## Acceleration



## RF amplifier



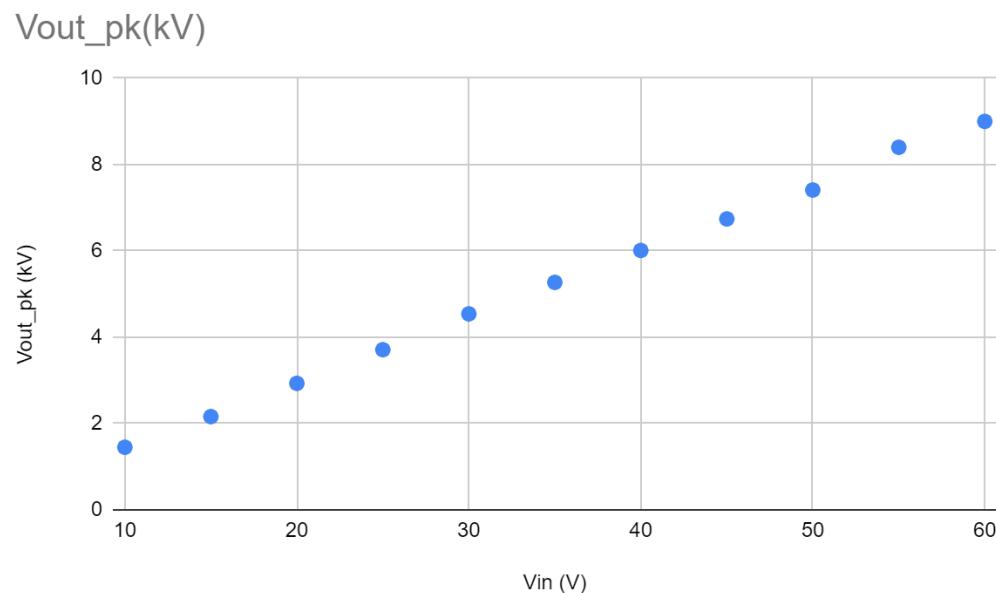
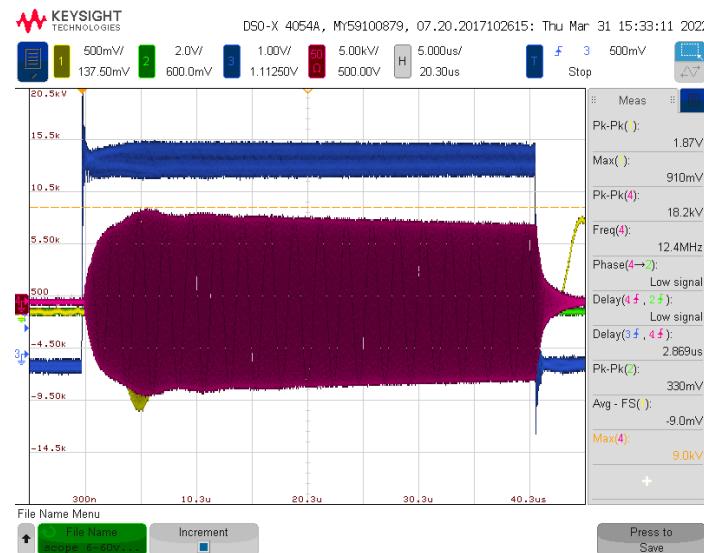
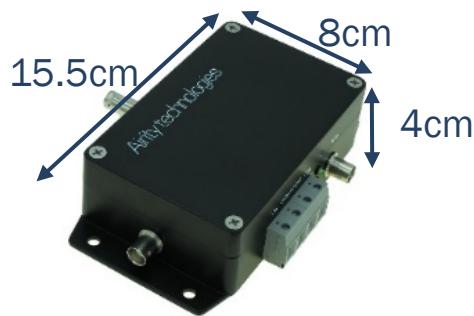
# Beam energy analyzer with parallel plates have been tested and calibrated with injected ions with known beam energy.



Q. Ji et al, Rev. Sci. Instrum. **92**, 103301 (2021);  
<https://doi.org/10.1063/5.0058175>

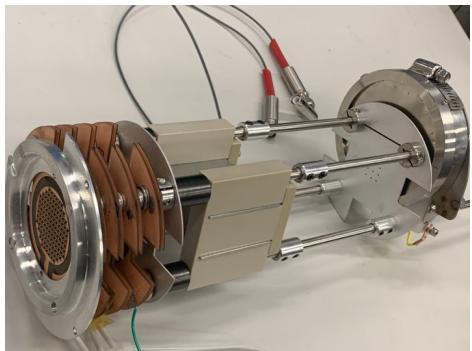
## Near board compact RF amplifier enables acceleration > 6 keV/gap.

## RF (13.5MHz) amplifier



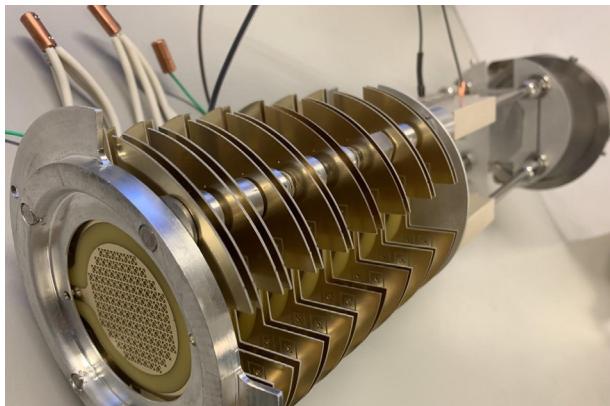
# We've made steady progress to achieve ion energy over 100 keV.

4 RF gaps

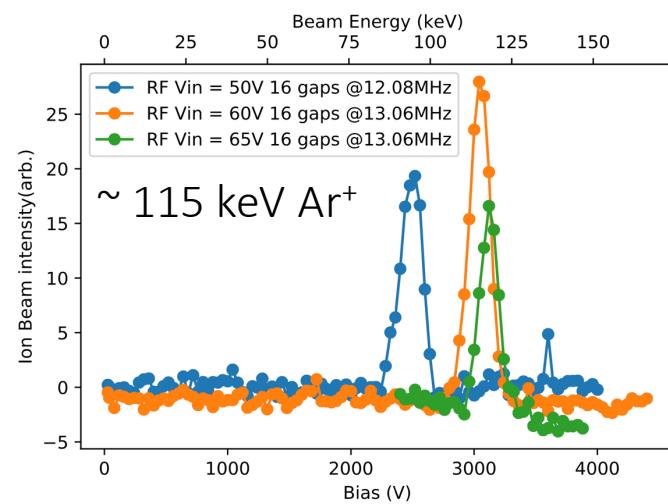
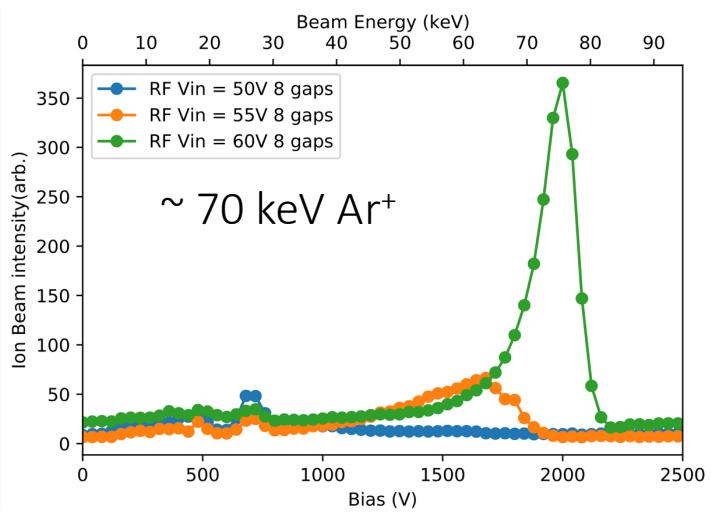
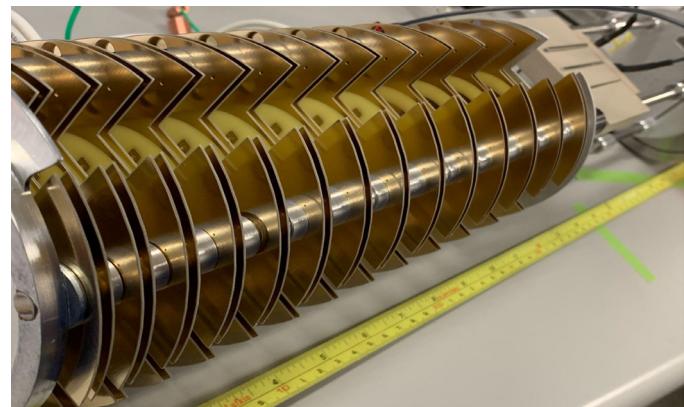


$\sim 33$  keV Ar<sup>+</sup>

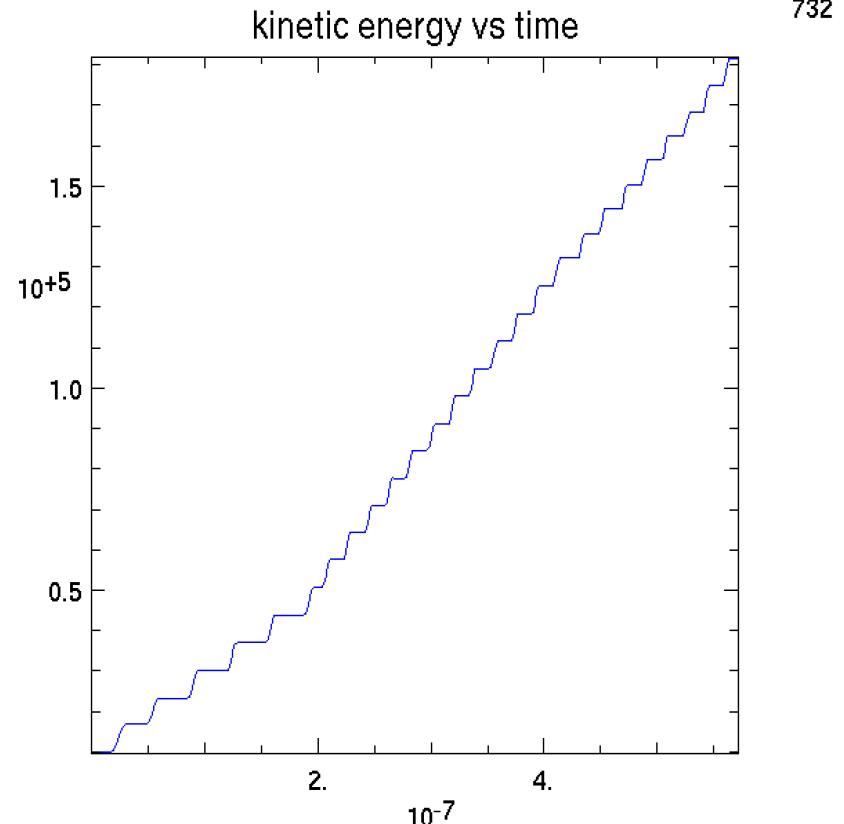
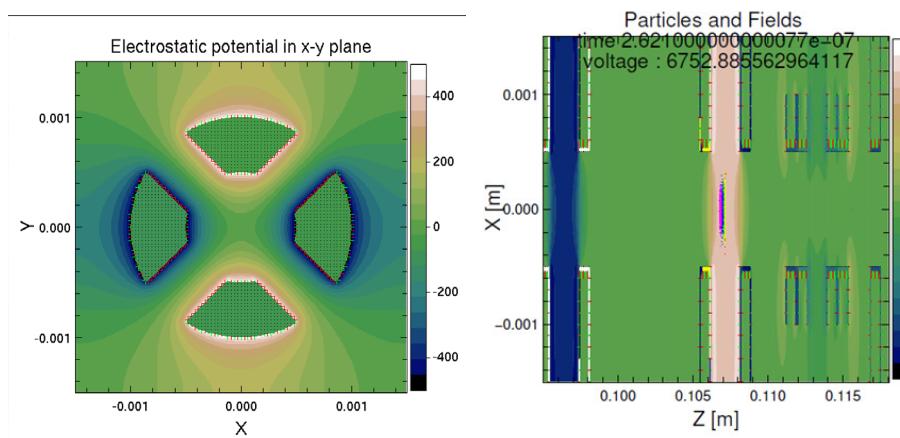
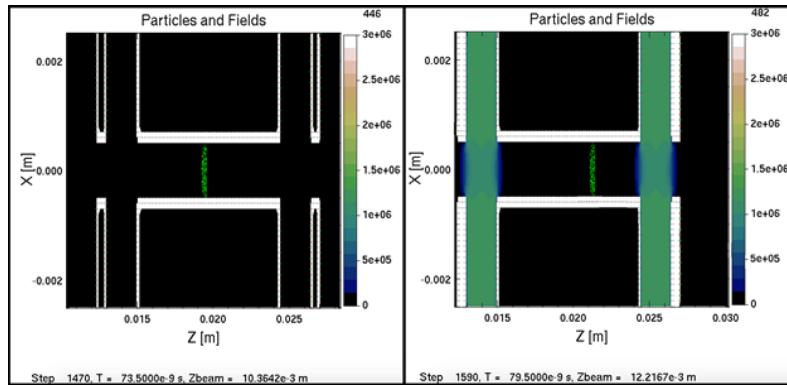
8 RF gaps



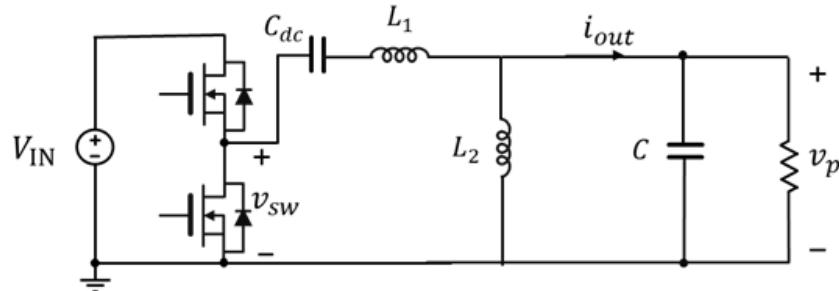
16 RF gaps



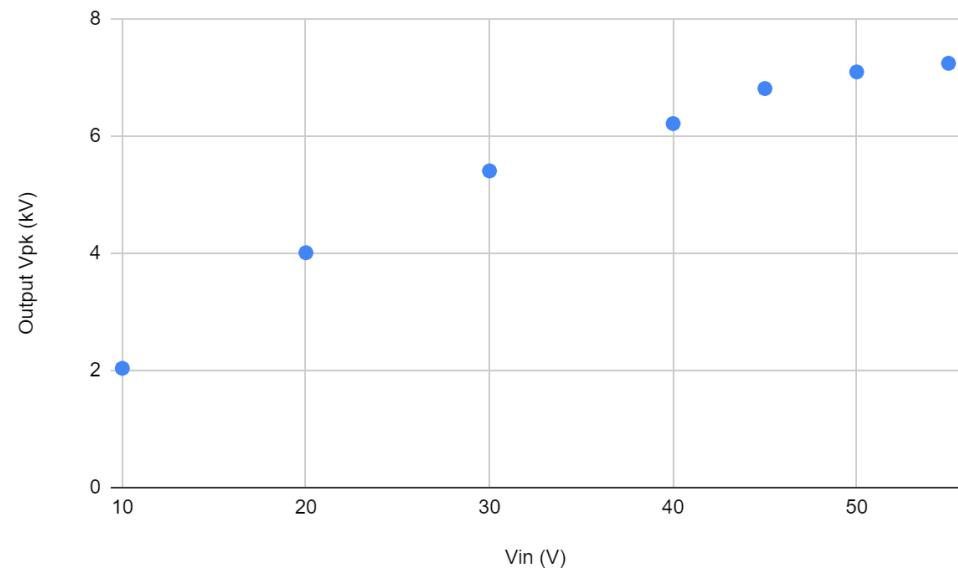
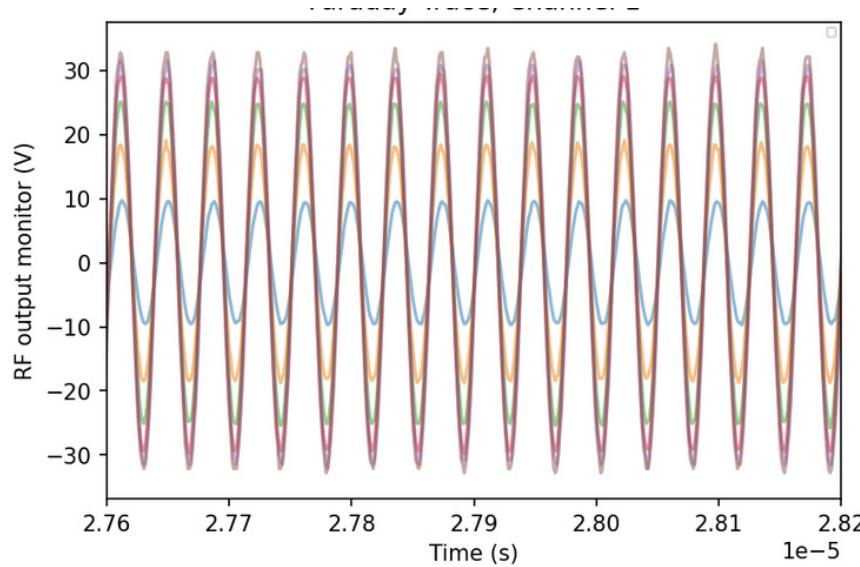
# WARP PIC simulations are set up to optimize ESQ parameters and help understanding of beam acceleration and transport.



# RF amplifiers at higher frequency are needed to improve the acceleration gradient.

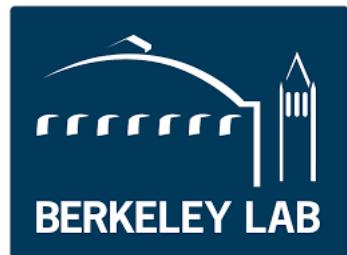
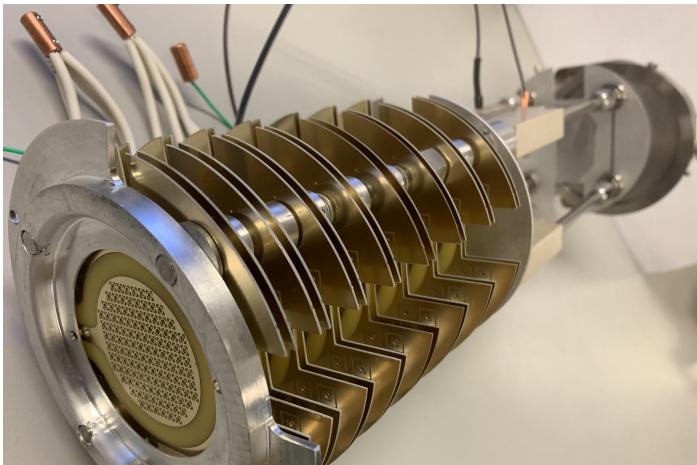


Half-bridge class-D circuit topology has been adopted for the 27MHz amplifier.



# Summary and outlook

- We are developing a new class of particle accelerators that can deliver more ions on target at lower cost.
  - 32 wafers (4"), 16 acceleration gaps, cost per wafer is less than 1\$
  - Injection energy 7 keV, up to 120 beamlets, peak argon ion current up to 0.5 mA
  - Acceleration by ~6.5 to 7.5 kV/gap, total energy added: ~100 keV, gradient 0.4 MV/m
- Minimal x-ray hazard, no large insulators to stand off high voltages
- Next steps is scaling to higher ion beam energy and ion current (>150 keV, >1 mA)
- This new class of particle accelerators can be applied to surface modification of materials, ion implantation, ion beam analysis, ...



Office of  
Science

ACCELERATOR TECHNOLOGY &  
APPLIED PHYSICS DIVISION



# Acknowledgements

Special thanks Takeshi Katayanagi for his dedicated technical support.

This work is supported by ARPA-E. Work at LBNL was conducted under the auspices of DOE contract DE-AC0205CH11231. Device fab at the Cornell Nano Fab facility was supported by NSF (Grant 384 No.ECCS-1542081).



U.S. DEPARTMENT OF  
**ENERGY**  
Office of  
Science

ACCELERATOR TECHNOLOGY &  
APPLIED PHYSICS DIVISION **ATAP**



# Thank you